

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of: Xuejun Kang, et al. Application No. 10/572,524 Filed: September 11, 2007 For: FABRICATION OF CONDUCTIVE METAL LAYER ON SEMICONDUCTOR DEVICES	Examiner: Jeremy J. Joy Art Unit: 2822 Confirmation No. 4739 CERTIFICATE OF TRANSMISSION I hereby certify that this correspondence is being submitted electronically via EFS Web on the date shown below. <u>/Adriana M. Garcia/</u> <u>June 30, 2010</u> <i>Adriana M. Garcia</i> <i>Date</i>
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Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

AMENDMENT

Sir:

In response to the Office Action mailed March 30, 2010, applicants respectfully request that the above-identified application be amended as follows.